

# Preliminary Results from the Laser System generating Quasi 3-D Ellipsoidal Photocathode Laser Pulses at PITZ

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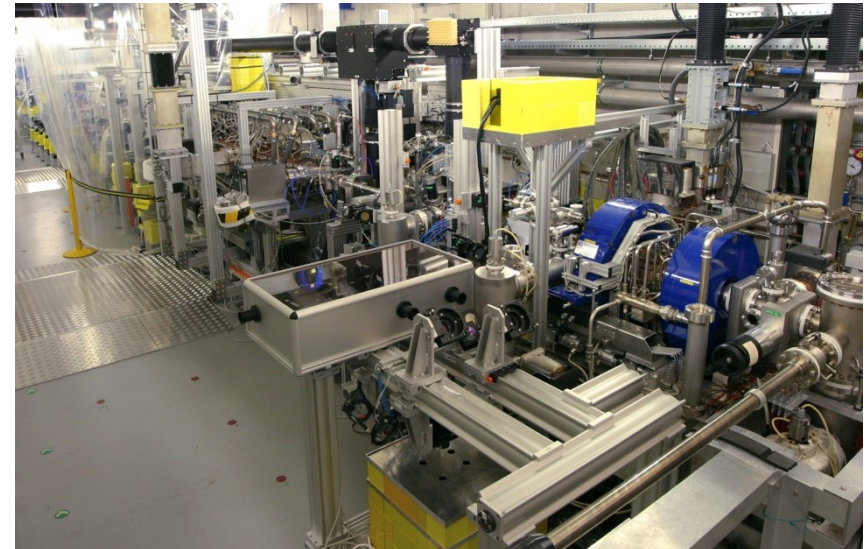
1. Introduction
2. Concept
3. First results
4. Conclusion

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12.03.2015

# 1.1 Photoinjector Test Facility

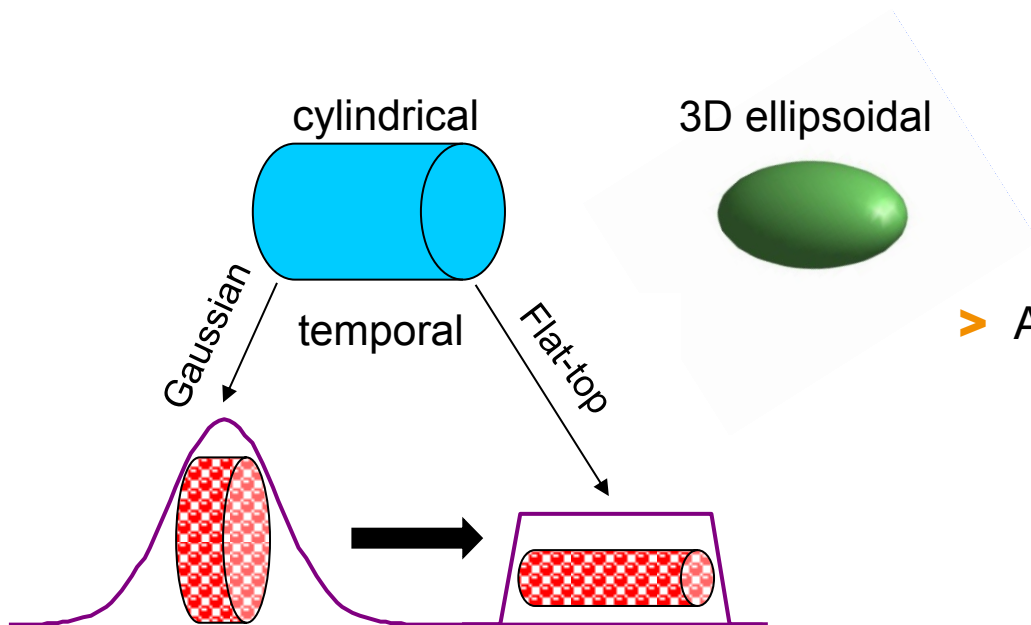
## Focus:

- Conditioning, characterization, testing, development, and optimization of high brightness electron sources for superconducting linear accelerator driven Free Electron Lasers (FELs), e.g. FLASH and the European XFEL



# 1.2 Introduction

> **Motivation:** Improve the electron beam quality by improving photocathode laser profile

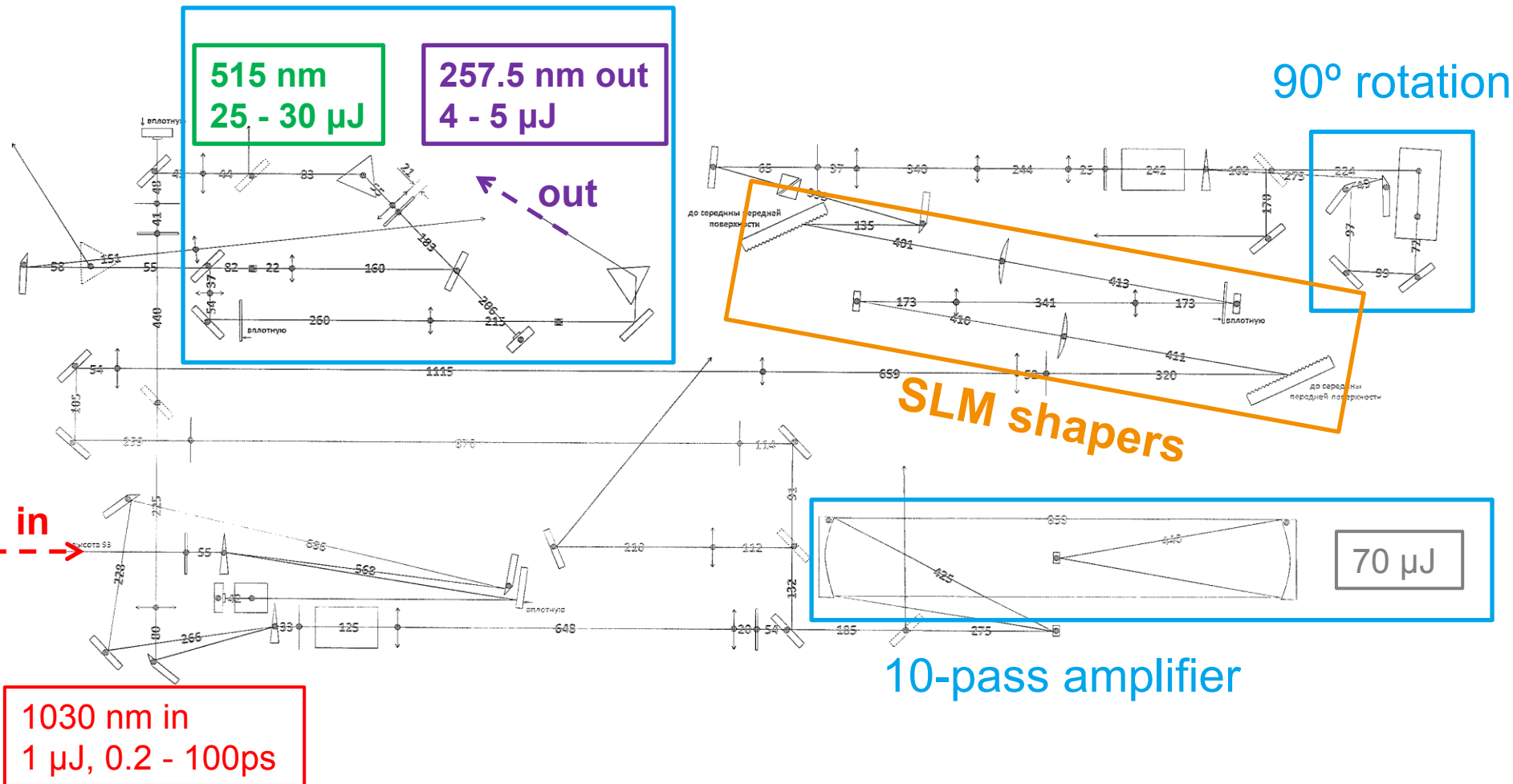


> Advantages:

- Minimizes space charge influence on emittance
- Improved longitudinal compress
- Reduced beam halo
- Reduced machine sensitivity

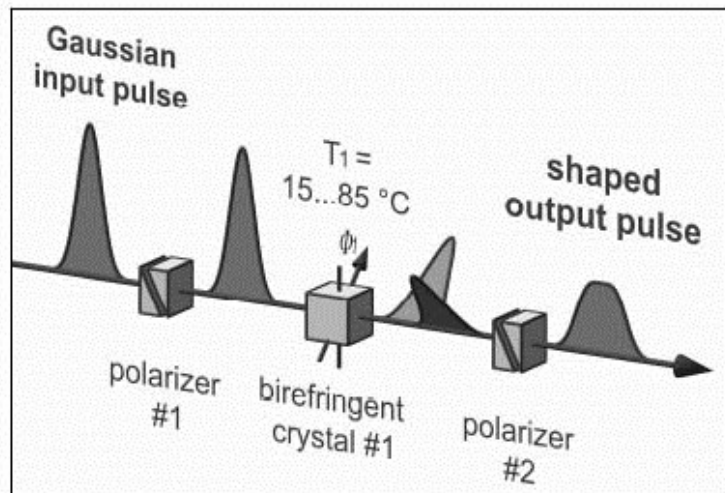
# 1.3 New laser optical layout

## harmonic generation

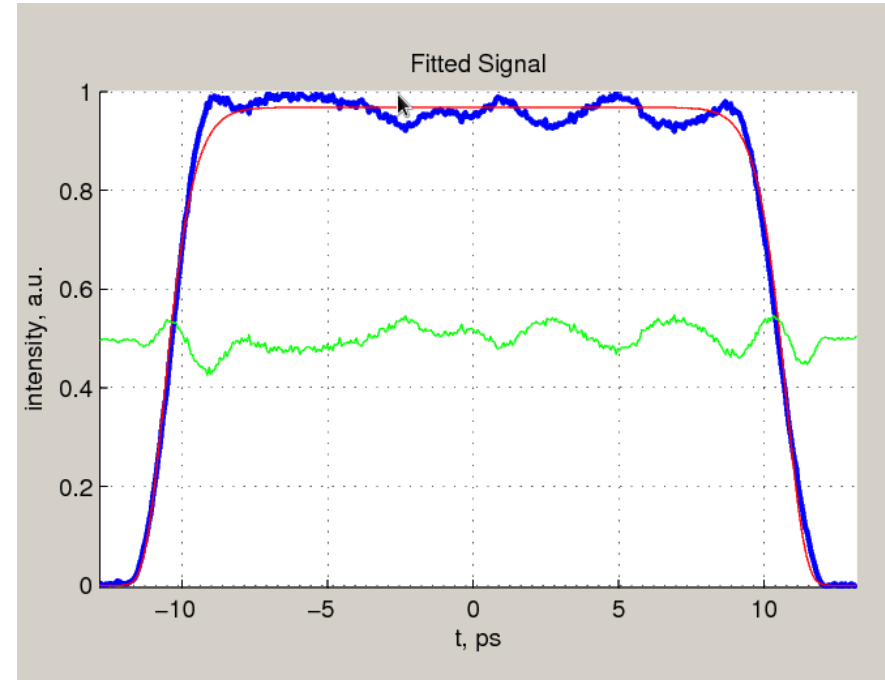


## 2.1 Current pulse shaper: Super-Gaussian

- „Generation of flat-top picosecond pulses by coherent pulse stacking in a multicrystal birefringent filter“, Ingo Will & Guido Klemz  
*Optics Express, Vol. 16, Issue 19, pp. 14922-14937 (2008)*



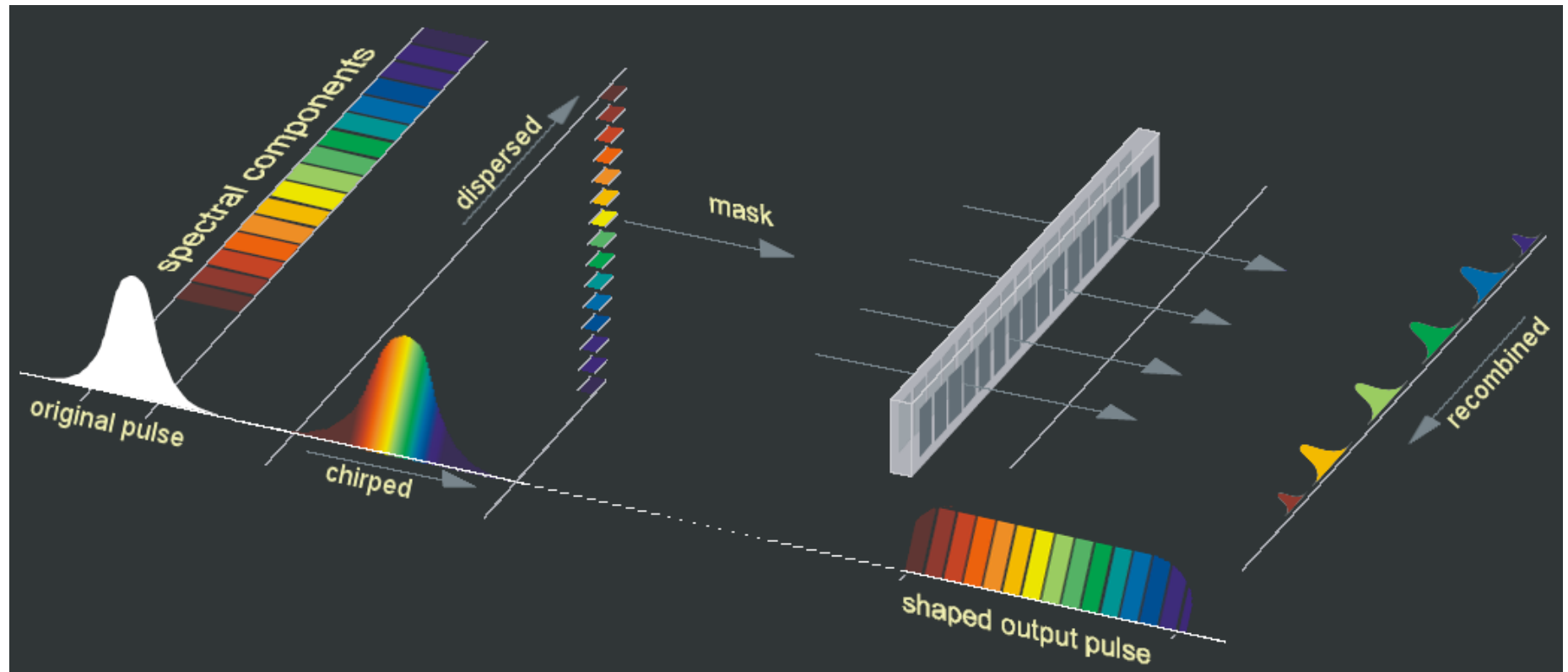
principle of operation



optically sampled 20 ps super-gaussian

## 2.2 Spectral mask-based pulse shaping

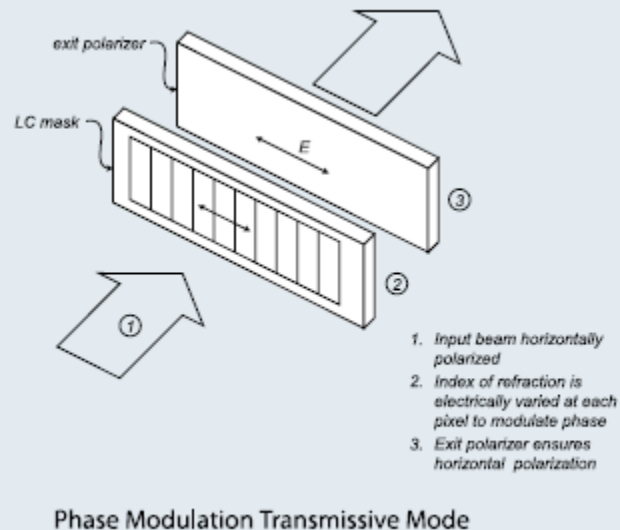
- Concept: Spectrally separated chirped pulse transversally modulated by amplitude-phase mask prior to recombination



## 2.3 Masks: Spatial Light Modulator (SLM)

### > Masks

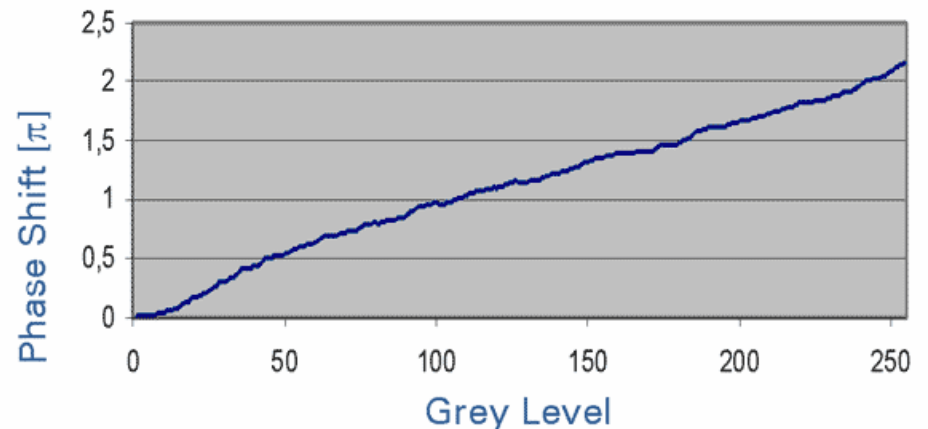
- Binary array
- Lithographic plates
- **Spatial Light Modulators**



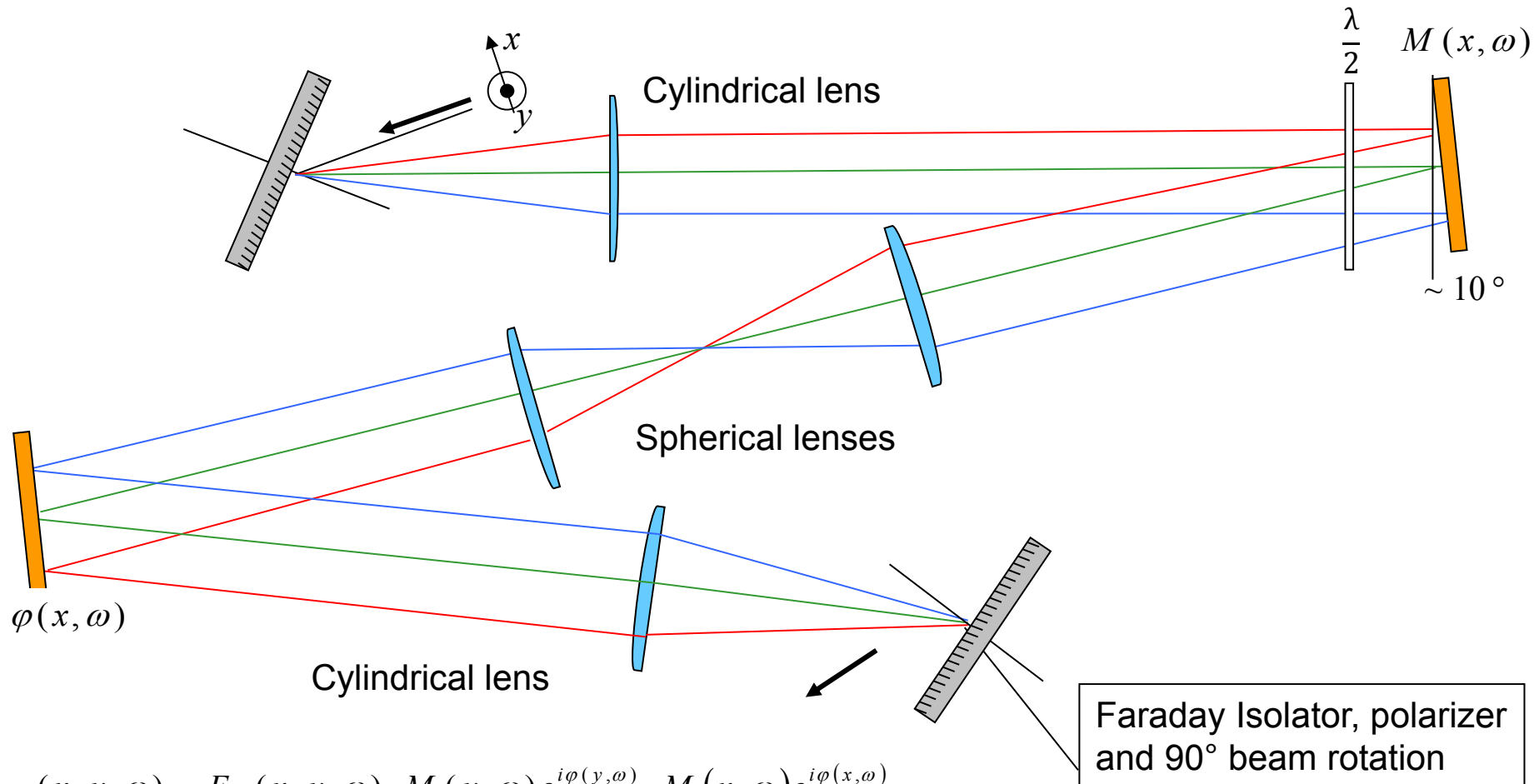
### > Holoeye Pluto

- High-resolution LCOS phase-only SLM
- 1920x1080 8  $\mu\text{m}$  matrix of 8-bit phase retarders

PLUTO-NIR with default settings @ 1064 nm



## 2.4 1D Spatial Light Modulator (SLM) shaping

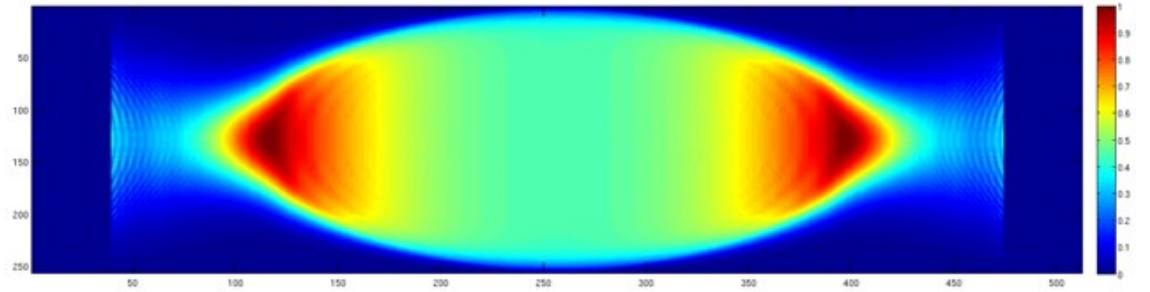


$$E_{out}(x, y, \omega) = E_{in}(x, y, \omega) \cdot M(y, \omega) e^{i\varphi(y, \omega)} \cdot M(x, \omega) e^{i\varphi(x, \omega)}$$

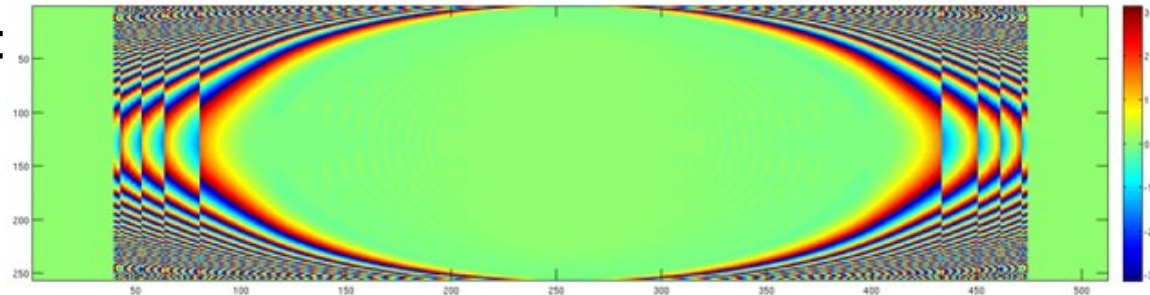


# 3.1 SLM mask simulations

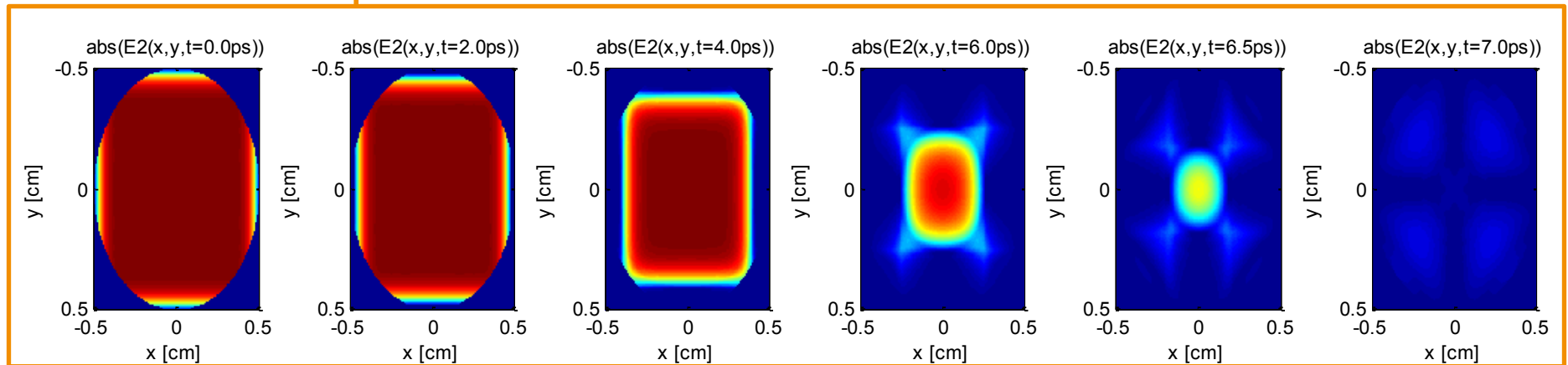
Amplitude mask:



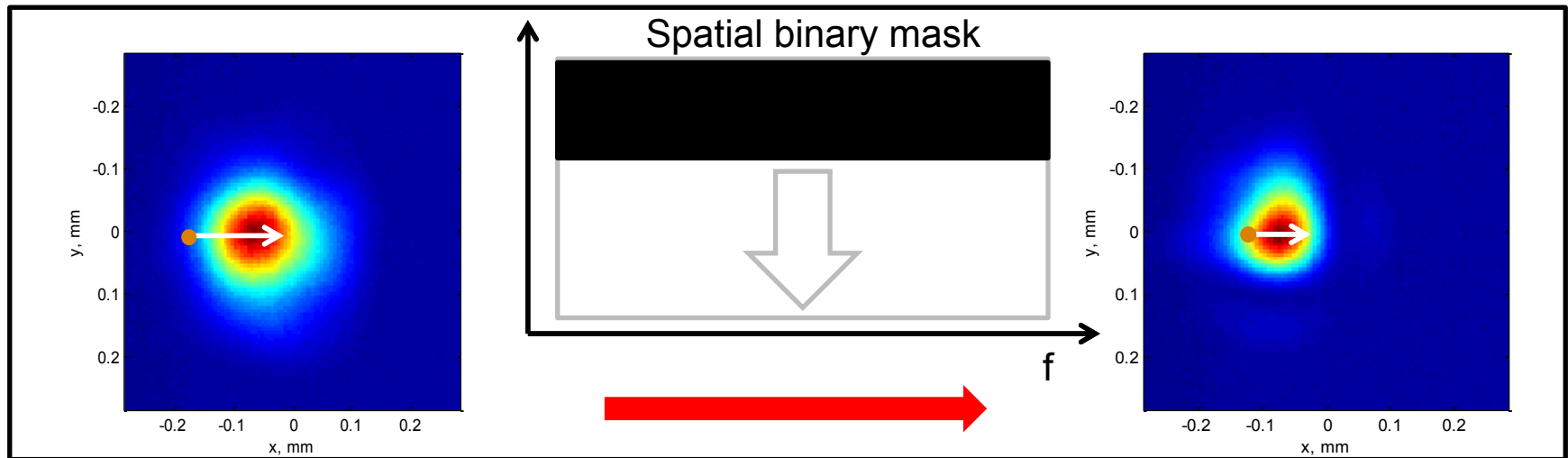
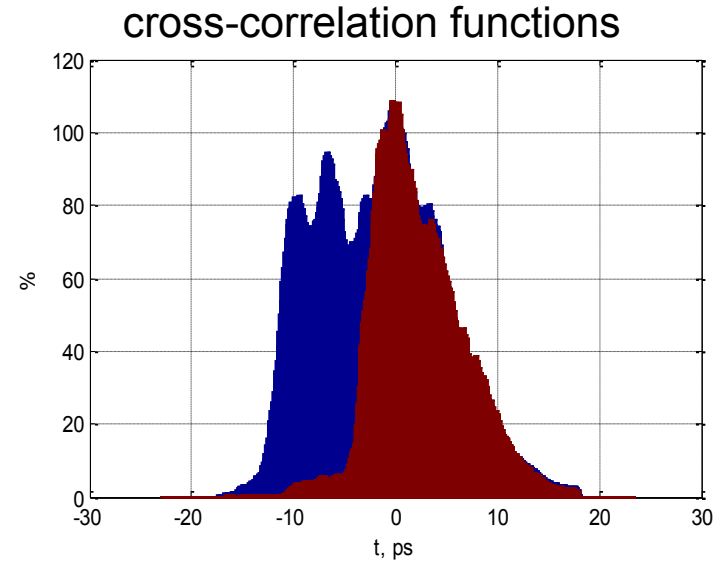
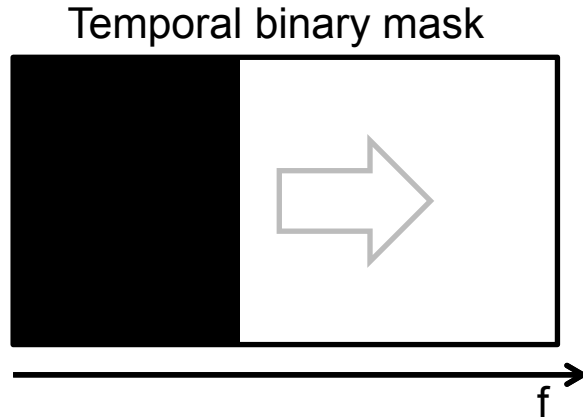
Phase mask:



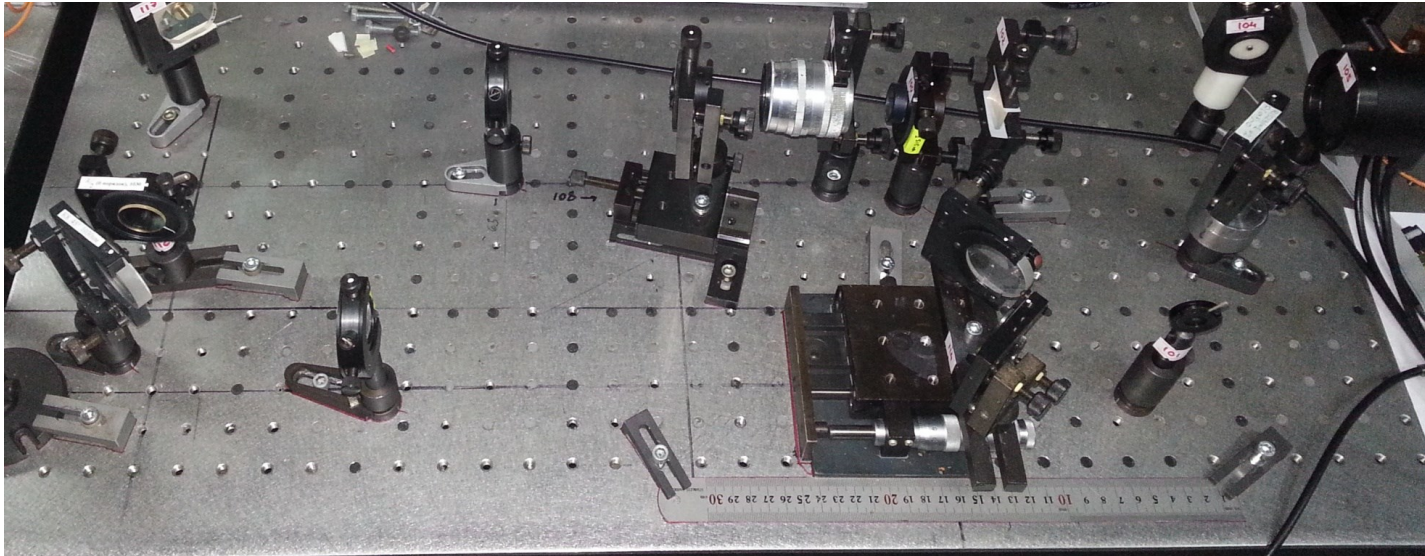
## Simulated temporal slices



# 3.2 Temporal and spatial correlation

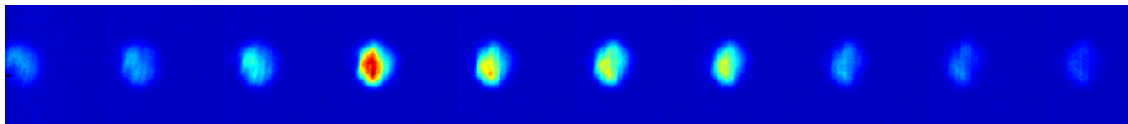


## 3.3 Cross-correlated camera images

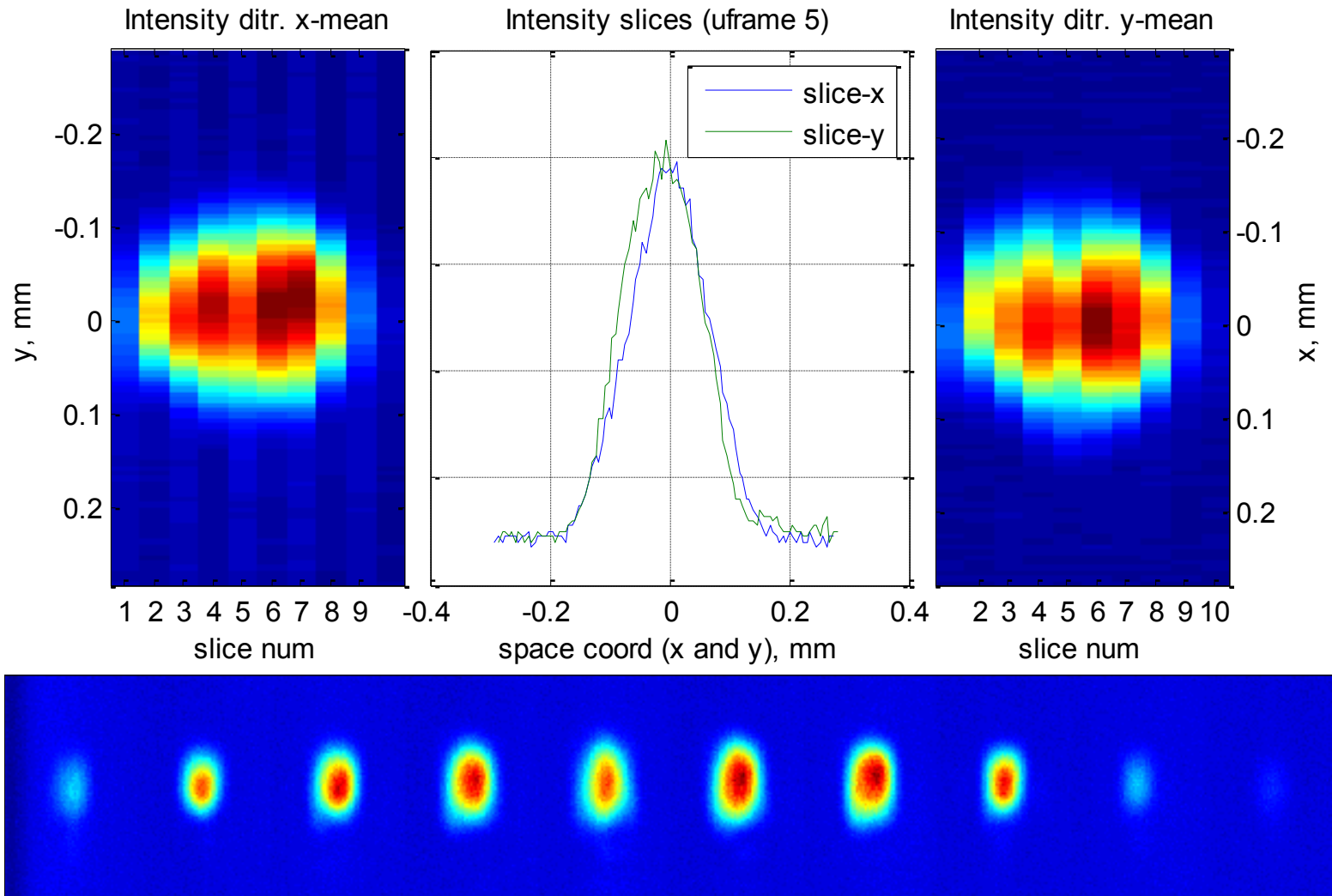


### Spatial shaping experiments:

Cross-correlation slices of laser pulses without shaping



# 3.4 Measured temporal laser pulse profiles



# 4. Conclusions and projections

## > In conclusion:

- Homogenous pulse with quasi-ellipsoidal envelope shown by simulations
- Laser system capable of producing quasi 3-D ellipsoidal laser pulses installed and undergoing commissioning
- Diagnostics implemented and utilized
- Temporal slicing and intensity modification demonstrated

## > Outlook

- Beam transport to cathode and generation of photoelectrons ongoing
- 1<sup>st</sup> electron beam characterization using shaped laser pulses
- Iterative/adaptive pulse shaping
- (Demonstrate improvement in electron beam quality)



# Thank you for your attention



# Backup slides



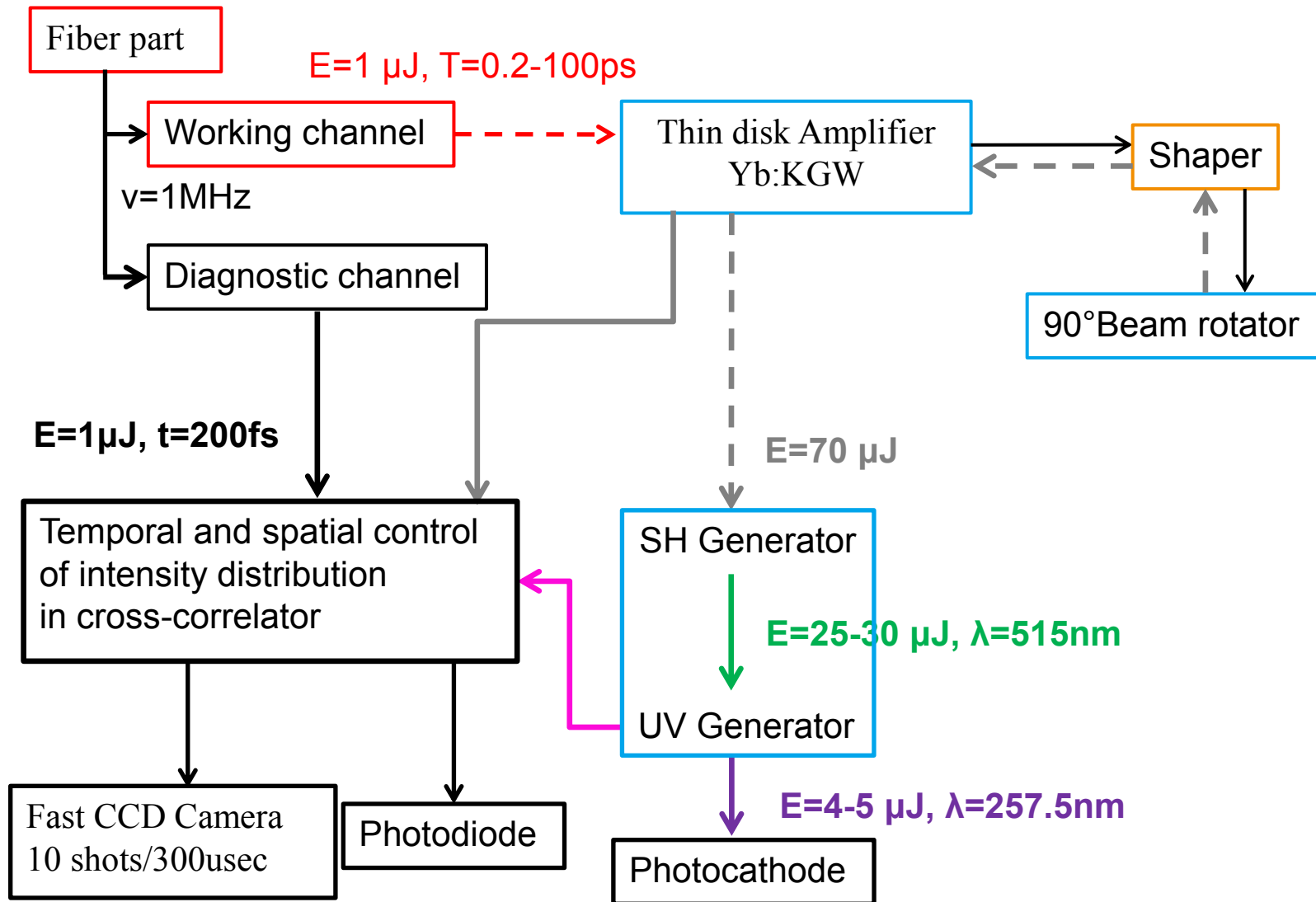
# Laser parameters

Parameter	Value	Unit	Remark
wavelength	255-270	nm	4 <sup>th</sup> harmonic of Nd
micropulse energy	10-12	μJ	for 1 nC bunch production from Cs <sub>2</sub> Te photo cathodes
pulse train frequency	1	MHz	In the future 4.5 MHz will be a goal
pulse train length	0.3	ms	In the future 0.6 ms will be a goal
pulse train rep.rate	10	Hz	1,2,5 Hz as an option
micropulse rms duration	6±2	ps	3D quasi ellipsoidal distribution
diagnostic pulse duration	150	fs	
transverse rms size	0.5±0.25	mm	





# General Scheme of PITZ Ellipsoidal Laser (ELLA)



# Perpendicular quantization

